

03500.016184.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
MINEO SHIMOTSUSA )  
Application No.: 10/067,904 )  
Filed: February 8, 2002 )  
For: SEMICONDUCTOR DEVICE, )  
METHOD OF MANUFACTURING: )  
THE SAME AND LIQUID JET )  
APPARATUS )  
Group Art Unit: 1746  
May 6, 2002

Commissioner for Patents  
Washington, D.C. 20231

SUBMISSION OF PRIORITY DOCUMENTS

Sir:

In support of Applicant's claim for priority under 35 U.S.C. § 119, enclosed are  
certified copies of the following foreign applications:

Japan 2001-040430, filed February 16, 2001; and

Japan 2001-040431, filed February 16, 2001.

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TO 11/3

Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
Attorney for Applicant

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